



35.C14386

PATENT APPLICATION

#6
C. Barnes
5-2-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE **RECEIVED**

In re Application of:)
SEIJI MISHIMA)
Application No.: 09/694,268)
Filed: October 24, 2000)
For: METHOD OF MANUFACTURING)
ELECTRONIC DEVICE,)
ELECTRON SOURCE)
SUBSTRATE, AND IMAGE)
FORMING APPARATUS, AND)
APPARATUS FOR)
MANUFACTURING ELECTRONIC)
DEVICE AND ELECTRON)
SOURCE SUBSTRATE)

Examiner: NYA
Group Art Unit: 3661

TO 3600 MAIL ROOM

FEB 09 2001

February 2, 2001

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

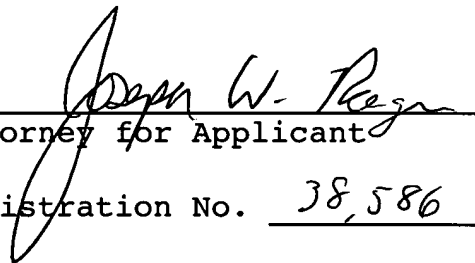
In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form PTO-
1449. Copies of the listed documents are also enclosed.

For the concise statement of relevance for the non-English documents, the Examiner is respectfully referred to the English Abstracts attached thereto.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
Registration No. 38,586

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
141719